



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Yoshimi SATO et al.

Serial No. 10/665,143 : **Attn: APPLICATION BRANCH**

Filed September 22, 2003 : Attorney Docket No. 2003_1356

COATING SOLUTIONS FOR USE IN
FORMING BISMUTH-BASED
FERROELECTRIC THIN FILMS AND
A METHOD OF FORMING BISMUTH-
BASED FERROELECTRIC THIN FILMS
USING THE COATING SOLUTIONS

: **Confirmation No. 5804**

PRELIMINARY AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated March 18, 2003 in the parent application, please amend the present application as follows: